

Amendments

In the specification.

On page 1, under "Related Applications" please delete the section and replace with the following new text.

Related Applications

AI This application claims priority under 35 U.S.C. § 119(e) from co-pending application serial number 60/298,878 filed June 19, 2001 and entitled "Advanced Process Control for Semiconductor Manufacturing Process."

This application claims priority under 35 U.S.C. § 119(e) from co-pending application serial number 60/305,798, filed July 16, 2001 and entitled "Feedforward and Feedback Control for Conditioning of Chemical Mechanical Polishing Pad."

This application claims priority under 35 U.S.C. § 119(e) from co-pending application serial number 60/318,743, filed September 12, 2001 and entitled "Feedforward and Feedback Control for Conditioning of Chemical Mechanical Polishing Pad."
